

I hereby claim the benefit under Title 35, United States Code, §120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code, §112, I acknowledge the duty to disclose information material to the patentability of this application as defined in Title 37, Code of Federal Regulations, §1.56 which occurred between the filing date of the prior application and the national or PCT international filing date of this application:

**Prior U.S. Applications:**

Serial No.

Filing Date

### Status

N/A

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

As a named inventor, I hereby appoint the following attorneys and/or agents to prosecute this application and transact all business in the Patent and Trademark Office connected therewith:

**All patent practitioners associated with Customer Number 32074.**

Send all correspondence to: Ira D. Blecker, Intellectual Property Law, IBM Corporation, Dept. 18G, Building 300-482, 2070 Route 52, Hopewell Junction, New York 12533.

**Direct Telephone Calls to: Ira D. Blecker at 845-894-2580**

Inventor: Anil K. Chinthakindi

**Signature:**

9/9/04  
Date

Residence: Seven Green Hill Drive, #34E  
Fishkill, NY 12533

Citizenship: IN

Post Office  
Address: Same as residence.

Inventor:

Anita <sup>AM</sup> Madan

Signature:

Anita Madan

09/10/04

Date

Residence:

38 Lindencrest Drive  
Danbury, CT 06811

Citizenship:

IN

Post Office

Address:

Same as residence.

Inventor:

Kenneth J. Stein

Signature:

Kenneth J. Stein

4-13-04

Date

Residence:

Three Harvest Common  
Newtown, CT 06482

Citizenship:

US

Post Office

Address:

Same as residence.

Inventor:

<sup>Kwong Hon Wong</sup>  
~~Kwong H. Wong~~

ybw 9/9/04

Signature:

ybw

9/9/04

Date

Residence:

42 Mina Drive  
Wappingers Falls, NY 12590

Citizenship:

US

Post Office

Address:

Same as residence.

## AUTHORIZATION TO ACT IN A REPRESENTATIVE CAPACITY

In re Application of: Anil K. Chinthakindi  
Application No. N/A  
Filed: N/A  
Title: Thin Film Resistors of Different Materials  
Attorney Docket No. FIS920040134US1  
Art Unit: N/A

-----  
The practitioner named below is authorized to conduct interviews and has the authority to bind the principal concerned. Furthermore, the practitioner is authorized to file correspondence in the above-identified application pursuant to 37 CFR 1.34:

Name: Eric W. Petraske  
68 Old Hawleyville Road  
Bethel, CT 06801  
Registration Number: 28,459  
Telephone: 203-798-1857

This is not a Power of Attorney to the above-named practitioner. Accordingly, the practitioner named above does not have authority to sign a request to change the correspondence address, a request for an express abandonment, a disclaimer, a power of attorney, or other document requiring the signature of the applicant, assignee of the entire interest or an attorney of record. If appropriate, a separate Power of Attorney to the above-named practitioner should be executed and filed in the United States Patent and Trademark Office.

Signature of Practitioner of Record

Name: Ira D. Blecker

Signature: 

Date: 9/20/04

Registration Number: 29,894  
Telephone: 845-894-2580

Declaration and Power of Attorney for  
Patent Application

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below next to my name; I believe I am the original, first and sole inventor (if only one name is listed below) or an original, first and joint inventor (if plural names are listed below) of the subject matter which is claimed and for which a patent is sought on the invention entitled

Thin Film Resistors of Different Materials

the specification of which (check one)

☒

is attached hereto.

☐

was filed on \_\_\_\_\_ as Application Serial No. \_\_\_\_\_ and was amended on \_\_\_\_\_.

I hereby state that I have reviewed and understand the contents of the above- identified specification, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information which is material to the patentability of this application in accordance with Title 37, Code of Federal Regulations, §1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, §119 of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

Prior Foreign Application(s):

Number

Country

Day/Month/Year

Priority Claimed

N/A